

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Tomoo Tsugawa, et al.

International PCT Application No.: PCT/JP99/04335

International Filing Date: 10 August 1999

US Serial No.: To Be Assigned

Group Art Unit: To Be Assigned

Filed: : July 18, 2001 (Herewith)

Examiner: To Be Assigned

For : METHOD AND DEVICE FOR DRYING SUBSTRATE

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to the duty of disclosure under 37 C.F.R. 1.56, Applicants are enclosing an Information Disclosure Citation Form (PTO-1449) which lists the references cited in the International Search Report accompanying the national stage documents. The relevance of the references is set forth in the noted International Search Report. Copies of the references cited are also enclosed.

It is respectfully requested that the cited documents be considered by the Examiner in the above-identified patent application and that the cited documents be made officially of record therein. It is further requested that a listing of the same appear on the face of any patent which may issue from this application.

Respectfully submitted,

SMITH, GAMBRELL & RUSSELL, LLP

By: 

Michael A. Makuch, Reg. No. 32,263
1850 M Street, N.W., Suite 800
Washington, D.C. 20036
Telephone: (202) 659-2811
Fax: (202) 263-4329

July 18, 2001